

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Appln. Of: SAMUKAWA et al.

Serial No.: 10/501,351

Filed: July 14, 2004

For: On-Wafer Monitoring System

Group: 1792 Confirmation No. 7535

EXAMINER: Dhingra, Rakesh Kumar DOCKET: SHIG CPTA0502FE

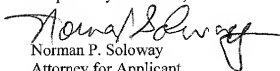
MAIL STOP ISSUE FEE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INTERVIEW SUMMARY

Dear Sir: \_\_\_\_\_

The Interview Summary attached to the Notice of Allowability and Notice of Allowance mailed December 23, 2008 accurately reflects the substance of the December 10, 2008 interview.

Respectfully submitted,

  
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CERTIFICATE OF ELECTRONIC FILING

I hereby certify that this correspondence is being deposited with the United States Patent Office via the electronic filing procedure on January 8, 2009.

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